

Koichiro Saga

List of Publications by Year in descending order

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2682572

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2272923

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#	ARTICLE	IF	CITATIONS
1	Behavior of Transition Metals Penetrating Silicon Substrate through SiO ₂ and Si ₃ N ₄ Films by Arsenic Ion Implantation and Annealing. ECS Journal of Solid State Science and Technology, 2015, 4, P131-P136.	1.8	18
2	Depth Profile Analysis of Metals Gettered by Oxide Precipitates in Silicon Substrates. ECS Journal of Solid State Science and Technology, 2017, 6, P231-P234.	1.8	3
3	<i>(Invited)</i> Metallic Contamination Issues in Advanced Semiconductor Processing. ECS Transactions, 2018, 86, 113-124.	0.5	2
4	(Invited) Metallic Contamination Issues in Advanced Semiconductor Processing. ECS Meeting Abstracts, 2018, , .	0.0	1
5	Depth Profile Analysis of Metals Gettered By Bulk Micro-Defects (BMDs) in Silicon Substrates. ECS Meeting Abstracts, 2016, , .	0.0	0